

Title (en)

Photocatalytic air treatment system and method

Title (de)

Fotokatalytisches Luftbehandlungssystem und -verfahren

Title (fr)

Système et procédé de traitement d'air photocatalytique

Publication

**EP 2361639 A3 20120118 (EN)**

Application

**EP 11167269 A 20080327**

Priority

- EP 08153442 A 20080327
- US 72894907 A 20070327

Abstract (en)

[origin: US2007251812A1] A photocatalytic air treatment system, including apparatuses and methods, for killing and/or mineralizing bacteria, viruses, mold, fungi, spores, mycotoxins, allergens, and other similar microorganisms or agents, and for oxidizing volatile organic compounds (VOCs). The system comprises one or more reactor beds configured in one or more stages with each reactor bed including a plurality of photocatalyst coated media substantially surrounding a plurality of sheathed ultraviolet light sources that may be arranged in a plurality of configurations. Adjacent ultraviolet light sources are positioned so as to create killing zones of photocatalyst coated media therebetween that are irradiated with ultraviolet light from multiple sources and in which an increased number of hydroxyl radicals are present. The photocatalyst generally comprises titanium dioxide, but may include one or more enhancers. The media is formed from or is coated with a material that induces the photocatalyst to form a nano-particle structure.

IPC 8 full level

**A61L 9/20** (2006.01)

CPC (source: EP US)

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Citation (search report)

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